13 TRIBHUVAN UNIVERSITY INSTITUTE OF ENGINEERING Examination Control Division 2075 Ashwin

Exam.		Back	
Level	BE	Full Marks	80
Programme	BEL, BEX	Pass Marks	32
Year / Part	II / I	Time	3 hrs.

[4]

[4]

[6]

[4]

[8]

101

Subject: - Electrical Engineering Material (EE502)

- \checkmark Candidates are required to give their answers in their own words as far as practicable.
- ✓ Attempt <u>All</u> questions.

-

- ✓ The figures in the margin indicate <u>Full Marks</u>.
- ✓ Assume suitable data if necessary.
- ✓ Values of commonly used constants are given below:

 $\begin{array}{ll} \mbox{Mass of electron, } m_e = 9.1 \times 10^{-31} \mbox{ kg} & 1 \mbox{ eV} = 1.6 \times 10^{-19} \mbox{ J} \\ \mbox{h} = 6.626 \times 10^{-34} \mbox{ Js} & k = 1.38 \times 10^{-23} \mbox{ J/K} \\ \mbox{Permittivity of Silicon, } \pmb{\epsilon} = \pmb{\epsilon}_r \mbox{ } \pmb{\epsilon}_o = 11.9 \times 8.85 \times 10^{-12} \mbox{ F/m} & \mu_e = 1350 \mbox{ cm}^2/\mbox{V.s (at 300 K)} \\ \mbox{n}_i = 1.45 \times 10^{10} \mbox{ cm}^{-3} \mbox{ for silicon} & N_A = 6.022 \times 10^{23} \mbox{ / mol} \\ \mbox{M}_A = 6.022 \times 10^{23} \mbox{ / mol} \\ \end{array}$

- 1. a) Derive the time independent Schrodinger's equation, starting with classical wave equation, $y = A \sin 2\pi \left(ft \frac{x}{\lambda} \right)$, where notations have their usual meanings. [8]
 - b) Find the probability that an energy state 5KT above the Fermi level will not occupied by an electron.
- 2. a) Draw a neat diagram of face centered cubic (FCC) unit cell crystal structure for copper and find
 - (i) Number of atoms per unit cell
 - (ii) Packing density
 - (iii)Atomic concentration if radius of copper atom is 0.128 nm (iv)Density of crystal given that atomic mass of Cu is 63.55 g mol⁻¹ [8]
 - b) What is an effective mass of a free electron? Show that effective mass of a free electron is equal to mass of free electron in vacuum. [1+3]
- 3. a) What is local field in polarization? Derive the Clasuius- Massotti equation for electronic polarization. [8]
 - b) Differentiate between Ferro and Piezo electricity.
- 4. a) Explain the significance of hysteresis loop while selecting materials for preparing magnetic materials. [4]
 - b) Explain the domain theory of magnetism in detail.
 - c) Define superconductor, critical magnetic field, and critical current density.
- 5. a) Explain how donor dopants contribute electrons in conduction band in n-type extrinsic semiconductor. Also prove that σ = neµ_e where symbols have their usual meanings.
 - b) A silicon wafer is uniformly doped with 10¹⁶ Boron atoms per cm³. Where will be the Fermi level compared to its intrinsic Fermi level? Where will be the Fermi level is shifted if the sample is further doped with 10¹⁷ antimony atom per cm³? [6]
- 6. a) Explain the diffusion process in semiconductor and derive the Einstein relation for diffusion process.
 - b) Derive an expression of a built-in potential and depletion width of a pn junction with

TRIBHUVAN UNIVERSITY 13 INSTITUTE OF ENGINEERING **Examination Control Division** 2074 Chaitra

Exam.		Regular	
Level	BE	Full Marks	80
Programme	BEL, BEX	Pass Marks	32
Year / Part	II / I	Time	3 hrs.

Subject: - Electrical Engineering Material (EE502)

- \checkmark Candidates are required to give their answers in their own words as far as practicable.
- ✓ Attempt <u>All</u> questions.
- \checkmark The figures in the margin indicate <u>Full Marks</u>.
- ✓ Assume suitable data if necessary.
- ✓ Values of commonly used constants are given below:

Mass of electron, $m_e = 9.1 \times 10^{-31}$ kg	$1 \text{ eV} = 1.6 \times 10^{-19} \text{ J}$
$h = 6.626 \times 10^{-34} \text{ Js}$	$k = 1.38 \times 10^{-23} \text{ J/K}$
Permittivity of Silicon, $\varepsilon = \varepsilon_r \ \varepsilon_o = 11.9 \times 8.85 \times 10^{-12} \ \text{F/m}$	$\mu_e = 1350 \text{ cm}^2/\text{V.s} (\text{at } 300 \text{ K})$
$n_i = 1.45 \times 10^{10} \text{ cm}^{-3}$ for silicon	$N_A = 6.022 \times 10^{23} / mol$
$\mu_h = 450 \text{ cm}^2/\text{V.s}$ (at 300 K)	

1.	a)	Calculate the temperature at which there is 98% probability that a state 0.3 ev below the fermi energy level will be occupied by an electron.	[4]
	b)	Prove that the energy of a particle confined in an infinite potential well is quantized. Also find the expression for normalized wave function.	[8]
2.	a)	Draw face centered cubic (FCC) unit cell and find body diagonal and packing density.	[6]
	b)	The conductivity and drift mobility of copper conductor is $63.5*10^6$ s/m and 43 cm ² /v/s. Calculate Fermi level for copper conductor.	[4]
3.	a)	Show that the dielectric loss per unit volume is a function of frequency of the applied field and the loss tangent.	[6]
	b)	What do you mean by piezo-electric materials? Explain piezoelectric effect in terms of polarization.	[4]
4.	a)	On the basis of magnetic vector, explain the ferromagnetism, ferrimagnetism and antiferromagnetism.	[4+2]
	b)	What is Meissner effect? Explain the difference between type I and type II superconductors. Type II superconductor is also called hard superconductor, why? [2+	-4+2]
5.	a)	Differentiate between non-degenerate and degenerate semiconductors.	[6]
	b)	What is Built-in potential and depletion width? Derive the expression of these with necessary diagram.	[6]
	c)	Calculate the resistance of pure silicon cubic crystal of 1 cm^3 at room temperature. What will be the resistance of the cube when it is doped with 1 arsenic in 10^9 silicon	
		atoms and 1 boron atom per billion silicon atoms? Atomic concentration of silicon is $5*10^{22}$ cm ⁻³ , ni = 1.45*10 ¹⁰ cm-3.	[8]
6.	a)	Calculate the diffusion coefficient of electrons at 300K in n-type silicon semiconductor. Also find current density if electron concentration gradient is 10^3 electrons per centimeter.	[4]
	b)	Obtain the expression to evaluate built in potential and width of depletion layer of p-n junction with necessary diagrams.	[10]

23 TRIBHUVAN UNIVERSITY INSTITUTE OF ENGINEERING Examination Control Division 2074 Abswin

Exam.			
Level	BE	Full Marks	80
Programme	BEL, BEX	Pass Marks	32
Year / Part	II / I	Time	3 hrs.

Subject: - Electrical Engineering Material (EE502)

✓ Candidates are required to give their answers in their own words as far as practicable.

- ✓ Attempt <u>All</u> questions.
- ✓ The figures in the margin indicate Full Marks.
- ✓ Necessary Graph is attached herewith.

E

- ✓ Assume suitable data if necessary.
- ✓ Value of commonly used constants are given below:

Mass of electron, $m_e = 9.1 \times 10^{-31} \text{ kg}$ $1 \text{ eV} = 1.6 \times 10^{-19} \text{ J}$ $h = 6.626 \times 10^{-34} \text{ Js}$ $k = 1.38 \times 10^{-23} \text{ J/K}$ Permittivity of Silicon, $\varepsilon = \varepsilon_r \varepsilon_o = 11.9 \times 8.85 \times 10^{-12} \text{ F/m}$ $\mu_e = 1350 \text{ cm}^2/\text{V.s}$ (at 300K) $n_i = 1.45 \times 10^{10} \text{ cm}^{-3}$ for silicon $N_A = 6.022 \times 10^{23} \text{ / mol}$

- 1. a) Explain the importance of quantum mechanics. Differentiate between classical and quantum mechanics with suitable examples.
 - b) In the photoelectric experiment, green light, with a wavelength of 522 nm is the longest wavelength radiation that can cause photoemission of electron from a clean sodium surface. Calculate the work function of sodium. If ultraviolet radiation with a wavelength 250 nm is incident to the sodium surface, what will be the kinetic energy of the photo-emitted electrons?
- 2. a) What happen when inter-atomic separation between two helium atoms is very less? Describe on the basis of formation of bonding and antibonding molecular orbital.
 - b) Prove that for a simple cubic structure, the lattice constant: $a = \left[\frac{NM}{\rho N_A}\right]^{1/3}$ where, N is the number of atoms per unit cell, M is atomic weight, N_A is Avogadro's number and ρ is density of crystal material.
- 3. a) Define local electric field and derive clausius-massotti equation. [6]
 - b) The number of electrons per unit volume of Silicon is 6×10^{22} cm⁻³. Calculate: [4]

i) Electronic polarizability due to valence electrons per Silicon atom.

ii) If the Silicon crystal sample is electrode on opposite faces, by how many times the local field is greater than the applied field?

4. a) What is a domain wall? How does a domain wall motion occur? [6]
b) Explain about the applications of soft magnetic materials. [4]

[8]

[4]

[6]

[4]

- 5. a) A superconductor in its superconducting state expels all the magnetic lines of forces, justify.
 - b) Explain how carrier concentration of an n-type extrinsic semiconductor depends on temperature with necessary diagram and graphs.
 - c) Four micrograms of antimony are thoroughly mixed in molten form with 100 gms of pure germanium. Find the density of antimony atoms, density of donated electrons and the total resistance of a bar of such n-type material of 2 cm long, 0.012×0.012 cm in cross-section. Take, density of Ge = 5.46 gm/cm³ and atomic weight of Sb = 121.76.
- 6. a) The current density in semiconductor devices is affected both by diffusion and drifting of electrons and holes, justify.
 - b) Sample of silicon wafer is doped with 10¹⁵ Antinomy atoms/cm³. Find the carrier concentrations, its resistance and the shift in Fermi level from its intrinsic Fermi level at 27°C. If this sample is further doped with 10²² Boron atoms/cm³, what will be the change in its resistance.
 - c) Show that in n-type semiconductor minority carries concentrations are suppressed.





Figure: log-log plot of drift mobility versus temperature for n-type Silicon sample.

[6]

[6]

[6]

[6]

[6]

[8]

23 TRIBHUVAN UNIVERSITY INSTITUTE OF ENGINEERING Examination Control Division 2073 Shrawan

Exam.	New Back	(2066 & Later	Batch)
Level	BE	Full Marks	80
Programme	BEL, BEX	Pass Marks	32
Year / Part	II / I	Time	3 hrs.

Subject: - Electrical Engineering Material (EE502)

- ✓ Candidates are required to give their answers in their own words as far as practicable.
- ✓ Attempt <u>All</u> questions.
- The figures in the margin indicate <u>Full Marks</u>.
- ✓ Assume suitable data if necessary.
- Values of commonly used constants are given below.
- ✓ Mass of electron ,me=9.1*10⁻³¹kg; 1ev=1.6*10⁻¹⁹J
- ✓ $h=6.65*10^{-34}$ Js; $k=1.38*10^{-23}$ J/k;
- ✓ Permittivity of silicon=ε₀ε₁=11.9*8.85*10⁻¹²F/m
- ✓ $n_{10}=1.45*10^{10}/\text{cm}^3$ for silicon; $\mu_n=1350\text{cm}^2/\text{v.s}(\text{at 300K})$
- $\checkmark \mu_h = 450 \text{ cm}^2/\text{v.s}(\text{at 300K});$ N_A=6.022*10²³/mol

1. a) What do you understand by number of states and density of states in quantum mechanics? Derive appropriate expressions for them.

- b) A transmitter type vacuum tube operated at 1500°C has a cylindrical Thorium coated Tungsten cathode which is 5 cm long with diameter of 1.5 mm. Determine the saturation current of vacuum tube if the cathode has emission constant of 3×10^4 Am⁻²k⁻² and work function of 2.6eV.
- 2. a) Define and explain the effective mass of electron within a crystal. How do you understand negative and infinite mass of electron?
 - b) For silver with $E_{FO} = 5.5$ ev and $\phi = 4.5$ ev, calculate the total number of states per unit volume and compare this with atomic concentration of silver. Density and atomic mass of silver are 10.5g/cm³ and 107.9g/mol respectively.
- a) Define local field in relation to polarization. Derive the Clausius-Massotti equation for ionic polarization, relating polarizability with the permittivity. [6]
 - b) Name the field of application of different types of dielectric materials.

4. a) Classify the magnetic material based on magnetization.

- b) What type of magnetic material would you chose for electromagnetic relays? Justify. [6]
- a) For a specimen of V₃Ga, the critical fields are 0.176T and 0.528T for 14K and 13K respectively. Calculate the critical temperature. Also calculate critical fields at 0K and 4.2K.
 - b) What is diffusion? Derive Einstein relationship for an n-type semiconductor.
 - c) A silicon ingot is doped with 10¹⁶ arsenic atoms/cm³. Find the carrier concentrations conductivity of the sample and the shift in Fermi level from its intrinsic Fermi level at 27°C.
- 6. a) Suppose a P-N junction is created on silicon wafer at room temperature. If the donor level on N-side is10¹⁷ cm⁻³ and acceptor level on P-Side is 10¹⁶ cm⁻³ calculate built in potential (V_o) and depletion width (W_o).
 - b) Calculate the resistance of pure silicon cubic crystal of 1 cm^3 at room temperature. What will be the resistance of the cube when it is doped with 1 arsenic in 10^9 silicon atoms and 1 boron atom per billion silicon atoms? Atomic concentration of silicon is $5*10^{22} \text{ cm}^{-3}$, $n_i = 1.45*10^{10} \text{ cm}^{-3}$.
 - c) What are energy bands? Distinguish between a conductor, an insulator and a semiconductor on the basis of energy diagram. Write two characteristic features to

[6]

[8]

[4]

[6]

[4]

[4]

[6]

[6]

[6]

[6]

[6]

TRIBHUVAN UNIVERSITY 23 INSTITUTE OF ENGINEERING **Examination Control Division** 2072 Chaitra

Exam.		Regular	
Level	BE	Full Marks	80
Programme	BEL, BEX	Pass Marks	32
Year / Part	II / I	Time	3 hrs.

Subject: - Electrical Engineering Material (EE502)

- ✓ Candidates are required to give their answers in their own words as far as practicable.
- ✓ Attempt All questions.

1

- ✓ The figures in the margin indicate *Full Marks*.
- ✓ Assume suitable data if necessary.
- ✓ Values of commonly used constants are given below.
- ✓ Mass of electron , m_e=9.1*10⁻³¹kg; 1ev=1.6*10⁻¹⁹J
- \checkmark h=6.65*10⁻³⁴Js; k=1.38*10⁻²³J/k:
- ✓ Permittivity of silicon=ε₀ε_r=11.9*8.85*10⁻¹²F/m
- $\sqrt{n_{10}=1.45^{*}10^{10}/cm^{3}}$ for silicon; $\mu_n = 1350 \text{ cm}^2/\text{v.s}(\text{at } 300\text{K})$

 $\checkmark \mu_h = 450 \text{ cm}^2/\text{v.s}(\text{at 300K});$ N₄=6.022*10²³/mol

1. a) Define Fermi Energy. What is the probability that an electron having energy less than Fermi energy will occupy an energy level at absolute zero temperature? Determine the expectation value for any property of a particle described by a wave function Ψ .

TOI
IXI
101

b) An electron is confined to an infinite potential well of size 0.1 nm. Calculate the ground energy of the electron and radian frequency. How this electron can be put to [4] the third energy level? 2. a) What is effective mass? The electron at the top of valence band is said to have [2+4] negative effective mass. Explain with the help of E-k diagram. b) Formation of H₂ molecule is more stable than the formation of H₃ molecule. Justify with the help of electron energy versus inter-atomic separation between H-atoms. [6] 3. a) Show that the dielectric loss per unit volume is a function of frequency of the applied [6] field and the loss tangent. b) Describe how thermal breakdown and electromechanical breakdown results in [4] dielectric breakdown in solids. c) Based on magnetization vector, explain the diamagnetism, ferromagnetism and ferrimagnetisms. [8] 4. a) Explain how strong magnetic field effects superconductor. Derive the relation of critical current in superconductor with necessary diagram. [8] b) How band bending occurs in semiconductors? Derive Einstein relationship. [10] c) If it is desired that the Fermi-level is to be raised to 0.1 eV above intrinsic Fermi-level at room temperature, what type of dopant is to be used? Determine its doping level. [6] 5. a) Present a comparison between Si and GaAs semiconductors with the help of their basic properties and E-k diagram. [6] b) Derive the expression of a built-in potential and depletion width of a pn junction with [8] necessary diagrams.

	23	TRIBHUVAN UNIVERSITY	Exam.		Regular	
	IN	STITUTE OF ENGINEERING	Level	BE	Full Marks	80
E	an	nination Control Division	Programme	BEL, BEX	Pass Marks	32
		2071 Chaitra	Year / Part	Π/Ι	Time	3 hrs.
		Subject: - Electrical	Engineering	Material (E	E502)	
	Ca Ati Th As V N N h n µ µ a)	andidates are required to give their and tempt <u>All</u> questions. The figures in the margin indicate <u>Full</u> sume suitable data if necessary. Falues of commonly used constants and Mass of electron $,m_e=9.1*10^{-31}$ kg; 1e =6.65*10 ⁻³⁴ Js; k= ermittivity of silicon= $\varepsilon_0\varepsilon_r=11.9*8.85*3$ $\omega=1.45*10^{10}/cm^3$ for silicon; μ_n $\omega=450 cm^2/v.s(at 300K)$; NA What is Thermionic emission and we the thermionic emission for Schottky Consider two copper wires separated 3 nm. The surface oxide layer offer	swers in their o <u>Marks</u> . e given below. $w=1.6*10^{-19}J$ $1.38*10^{-23}J/k;$ $10^{-12}F/m$ $=1350cm^2/v.s(a)$ $=6.022*10^{23}/m.$ y ork function? If y effect. d only by their so	wn words as fa wn words as fa d Derive the Ric surface oxide l rier of height	hardson's expression of the target (CuO) of the target target the target target target the target ta	ssion for [8] hickness nduction
•		electrons in copper. What is the t copper, which have kinetic energy o	ransmission pr f about 7eV?	obability for	conduction elec	trons in [4]
2.	a)	structure of chromium and determ number.	al and draw a line its packin	neat diagram g density and	of body centered state its co-or	d cubic dination [2+4]
	b)	What is an effective mass of a free is equal to mass of free electron in v	electron? Show acuum.	that effective	mass of a free	electron [1+3]
3.	a)	What are the different types of polar	ization mechan	ism in di-elect	ric medium?	[6]
	b)	Describe how thermal breakdown a breakdown in solids.	nd electromech	anical breakdo	own results in d	ielectric [4]
4.	a)	Explain deperming method of dema magnetic field what will happen?	agnetization. If	you place gra	aphite in a non-	uniform [3+3]
	b)	What are magnetic domains? Expla external magnetic field.	in the behavior	r of magnetic	domains in pres	sence of [1+3]
5.	a)	What is Meissner effect? Explain in	brief about type	e-I and type-II	superconductor	. [8]
	b)	Differentiate Non-Degenerate and D	egenerate semi	conductors.		[4]
6.	a) b)	In doped semiconductors, carrier dependent on temperature, justify. Compute the intrinsic concentration that: $m_e^* = 1.08m_e$ $\mu_e = 1350$ G Where, m_e^* and m_h^* are effective ma are electron and hole drift mobility's	concentration n and intrinsic cm ² /V.s m _h * asses of electro respectively. T	and drift more resistivity of $= 0.6m_e \mu_h$ n and holes result he band gap of	bility both are silicon at 27°C = 450 cm ² /V.s spectively and μ f Silicon = 1.1 e	highly [6] . Given [6] . and µ _h V
7.	a) b)	Find the resistance of 1 cm ³ silicon of that every Arsenic atom sites every 5×10^{22} cm ⁻³ , $n_i = 1 \times 10^{10}$ cm ⁻³ , μ_e = resistance if the above silicon sample such that every Boron atom sites ever Prove that the position of Fermi let semiconductor.	crystal doped w 10^9 silicon ator = 1350 cm ² V ⁻¹ le is further dop ry 10 ⁶ silicon a evel is near the	with arsenic, the ns. Atomic co s ⁻¹ and $\mu_h = 4$ ped with Boro toms. middle of ba	e doping density ncentration of si $50 \text{ cm}^2 \text{V}^{-1} \text{s}^{-1}$. F n, the doping de- and gap in pure	is such ilicon is ind the ensity is [8] silicon [6]

*** - -- --.....

23 TRIBHUVAN UNIVERSITY INSTITUTE OF ENGINEERING Examination Control Division

2070 Chaitra

Exam.			
Level	BE	Full Marks	80
Programme	BEL, BEX	Pass Marks	32
Year / Part	Π/Ι	Time	3 hrs.

Subject: - Electrical Engineering Material (EE502)

- \checkmark Candidates are required to give their answers in their own words as far as practicable.
- ✓ Attempt <u>All</u> questions.
- ✓ The figures in the margin indicate *Full Marks*.
- ✓ Assume suitable data if necessary.

 \checkmark Values of commonly used constants are given below.

- ✓ Mass of electron , $m_e=9.1*10^{31}kg;$ 1ev=1.6*10⁻¹⁹J
- \checkmark h=6.65*10³⁴ Js; k=1.38*10⁻²³ J/k;
- ✓ Permittivity of silicon=ε₀ε_r=11.9*8.85*10⁻¹²F/m
- ✓ n_{i0} =1.45*10¹⁰/cm³ for silicon; μ_n =1350cm²/v.s(at 300K)

✓ μ_h =450 cm²/v.s(at 300K); N_A=6.022*10²³/mol

1.	a)	From free electron theory of metal, show that E-K diagram is parabolic. Also show the energy of electron in a linear metal is quantized.	[4+4]
	b)	Find the wavelength of an electron accelerated by 100V.	[4]
2.	a)	Explain with neat diagram how energy levels are filled and different energy bands are formed when N numbers of Lithium atoms are brought together.	[6]
	b)	Calculate the lattice constants, face diagonal, body diagonal and packing density of body centered cube (BCC) crystal unit cell.	[4]
3.	a)	What are the different types of dielectric breakdown? Explain any two of them.	[4]
	b)	Explain mathematically how relative permittivity is related with electronic polarizability using Clausius Massoti equation.	[6]
4.	a)	A crystal of iron created magnetic field around it but a piece of iron doesn't why?	[6]
	b)	How hysteresis loop plays an important role in classifying magnetic materials? Explain.	[4]
5.	a)	Define Critical magnetic field and Critical current in a super-conductor with mathematical relation involved.	[8]
	b)	What is reverse saturation current in pn junction semiconductor?	[4]
6.	a)	Derive the Einstein relationship showing the relation between electron diffusion co-efficient in n-type semiconductor and electron mobility.	[8] .
	b)]	Explain how PN junction is formed when n-type and p-type semiconductor are brought together. Derive the relation of built-in-potential of a PN junction.	[6]
7.	a)	Calculate the resistance of pure silicon cubic crystal of 1 cm ³ at room temperature. What will be the resistance of the cube when it is doped with larsenic in 10^9 silicon atoms and 1 boron atom per million silicon atoms? Atomic concentration of silicon is $5*10^{22}$ cm ⁻³ . Use other required data from above given list.	[8]
	b)	An n-type semiconductor doped with 10^{16} cm ⁻³ phosphorus atoms has been doped with 10^{16} cm ⁻³ boron atoms. Calculate the electron concentration in the semiconductor.	[4]

								· · · ·	y dia man	
									400 -	
_		24	TRIBHUVAN UNIVERSITY	Exam.	R	legular / Back	·····		a ana garife	
		IN:	STITUTE OF ENGINEERING	Level	BE	Full Marks	80			
	Ex	an	ination Control Division	Programme	BEL, BEX	Pass Marks	32			
			2068 Baishakh	Year / Part	II / I	Time	3 hrs.]		
_			Subject: - Electric	al Engineerir	ng Material				1	1 A A
	.√	Ca	ndidates are required to give their an	swers in their o	wn words as fa	ar as practicable				
	\sim	Att	empt <u>All</u> questions.	26.1						
_	. √	In	e figures in the margin indicate <u>Full</u> sume suitable data if necessary	Marks.			•		-	
	√	h =	$= 6.624 \times 10^{-34}$ IS	$lev = 16 \times l$	0 ⁻¹⁹ I					
_	\checkmark	<i>k</i> =	$= 1.38 \times 10^{-23} JK^{-23}$	$n_i = 1.45 \times 10^{-10}$	$\frac{10}{cm^3}$ for s		2VA			
	\checkmark	μ _n	$= 1350 cm^2 v^{-1} s^{-1}$ (at 300K):	$\mu_{h} = 450 cm^{2}$	$v^{-1}s^{-1}$ (at 300K))	<u> </u>			
	\checkmark	ε =	$= \varepsilon_0 \varepsilon_r = 11.9 \times 8.85 \times 10^{-12} F/m;$	Eg = 1.1ev	(6 da			
_	\checkmark	NA	$= 6.624 \times 10^{-23}$ /mol	$e = 1.602 \times 1$	0 ⁻¹⁹ C		<u> </u>			
	\checkmark	M_{a}	$t_{t} = 16g/mol \ (oxygen)$	Mass of photo	$n = 1.673 \times 10^{-10}$	$\Gamma^{27}kg$				
	\checkmark	Ve	locity of light = 3×10^8 m/s	~ ~	•					
_			•		•					
	1.	a)	From the expression $E_h = \frac{h^2}{2m^{12}}(h_x)$	$^{2} + h_{y}^{2} + h_{z}^{2}$),	define number	of states and de	ensity			
_			of states functions in quantum mech	anics Derive a	nnronriate exr	pressions for the	m	[6]	•	
							1	[0]		
-		D)	area of scattering is $3.9 \times 10^{-22} \text{m}^2$ conductivity of copper. Given dens	trons in copper . Estimate the ity of copper is	drift mobili 8.96g/cm ³ ar	s. The cross sec ty of electrons ad the atomic m	ass is	[6]		
	า	خ	Show that affective man of an alo	tran incide the	onvetel is inte	malumonartic	nalto	L-J	-	
	۷.	a)	the curvature of energy with respect	to wave numb	er space.	ersely proportio	nai to	[6]		
_	•	b)	Copper has FCC (Face- centered atomic concentration for copper if r	- cubic) struct adius of copper	ure. Find the atom is 0.128	packing density	y and 7 1 10	[4]		
	3.	a)	Define local field in relation to po for ionic polarization, relating polar	larization. Deri izability with th	ive the Clausi ne permittivity	us-Massotti Equ 7.	uation	[10]		
-		b)	Classify the magnetic materials be	ased on magne	tization and e	explain each of	them	[10]	-	
	Λ	2)	What is superconductor? Differenti	nta hatuvaan Tu	ne I and Type	II superconduct	tor 1	[10] [3+5]		
)	+ .	<i>aj</i>	That is superconductor? Differenti	are between i y	po-ranu rype	- II superconduce		<u>[</u>].]		
ه		b)	Explain how donor dopants con	tribute electron	ns in conduc	tion band in I	n-type			
_			extrinsic semiconductor. Also provi their usual meanings.	e that conductiv	vity $\sigma \simeq e n \mu_e$; where symbols	s have	[10]		
	5.	a)	A pn-junction is formed at 300k. T n-side are 10^{16} cm ⁻³ and 10^{17} cm ⁻³ r	he acceptor and espectively. Fin	d donor conce d :	ntration in p-sic	le and	-		
			 i) Built-in potential ii) Width of deplection layer iii) Maximum electric field iv) Width in n and p sides v) Fermi level n and p sides 		•			[2.5] [2.5] [1] [2]. [2]		
-		b)	Explain the diffusion process in diffusion process.	semiconductor	and derive	Einstein relatio	on for	[10]		- A for the second s
				***				- 4. -		and for some land
								·		

24 TRIBHUVAN UNIVERSITY INSTITUTE OF ENGINEERING Examination Control Division

2068 Chaitra

Exam.		Regular	
Level	BE	Full Marks	80
Programme	BEL, BEX	Pass Marks	32
Year / Part	11 / I	Time	3 hrs.

Subject: - Electrical Engineering Material (EE 502)

- ✓ Candidates are required to give their answers in their own words as far as practicable.
- ✓ Attempt <u>All</u> questions.
- ✓ The figures in the margin indicate <u>Full Marks</u>.
- ✓ Assume suitable data if necessary.
- ✓ Mass of electron $me = 9.1 \times 10^{-31} kg$; $k = 1.38 \times 10^{-23J}/K$; $h = 6.65 \times 10^{-34} JS$; $1eV = 1.6 \times 10^{-19} J$; $ni = 1.45 \times 10^{10}/cm^3$ for Si;
- ✓ $\mu_h = 450 \text{ cm}^2 \text{v}^{-1} \text{S}^{-1}$ (at 300K); $\mu_e = 1350 \text{ cm}^2 \text{V}^{-1} \text{S}^{-1}$ (at 300K);
- \checkmark N_A = 6.022 × 10²³/mol;
- 1. a) What do you mean by barrier penetration? How the wave function of particle is given when the particle penetrates the barrier? [8] b) A transmitter type vacuum tube has a cylindrical cathode, which is 4m long and 2mm diameter. Estimate the saturation current if the tube is operated at 160°C. The emission constant $A_0 = 3 \times 10^4 \text{ Am}^{-2} \text{K}^{-2}$, work function $\phi = 2.6 \text{ eV}$. [4] c) Conduction electrons with drift mobility of $53 \text{cm}^2 \text{V}^{-1} \text{S}^{-1}$ and mean speed of $2.2 \times 10^{6} \text{ms}^{-1}$ collides. Calculate the mean free path of electrons between collision. [4] 2. a) Explain, how energy bands are formed in solids taking the example of N number of Lithium atoms for the explanation. [6] b) What is electric dipole moment? Derive the Clausius- Masotti equation for electronic polarization, relating polarizability with the permittivity. [3+7]a) What is the significance of Hysteresis loop? Explain. [4] 3. b) Explain the domain theory of magnetism. [6] c) A p-n junction is made by silicon doped with 10^{17} donor atoms per cm³ with silicon doped 10¹⁶ acceptor atoms per cm³ at room temperature. Calculate built in potential across the junction and diffusion co-efficient in both parts. [6] 4. a) A pn junction is formed at 300k. The acceptor and donor concentration in p-side and n-side are 10¹⁸ cm⁻³ and 10¹⁶ cm⁻³ respectively. Calculate: [8] i) Built in potential ii) Width of deplection layer iii) Maximum value of electric field b) What is Meisner effect? Explain the difference between type I and type II [2+6]superconductors. 5. a) Explain about intrinsic Fermi level of a pure semiconductor and derive a relationship of the intrinsic Fermi level assuming that intrinsic carrier concentration is known. [2-74]b) Explain how carrier concentration of a semi-conductor depends on temperature with necessary diagrams and graphs. [6] What do you understand by diffusion of charge carriers in semiconductor? How does c) diffusion contribute to conductivity of a semiconductor? [4] 1.2.3